1. Record Nr. UNINA9910254194103321 Autore Zhang Xiao-Sheng Titolo Micro/Nano Integrated Fabrication Technology and Its Applications in Microenergy Harvesting / / by Xiao-Sheng Zhang Berlin, Heidelberg:,: Springer Berlin Heidelberg:,: Imprint: Springer, Pubbl/distr/stampa , 2016 **ISBN** 3-662-48816-7 Edizione [1st ed. 2016.] Descrizione fisica 1 online resource (137 p.) Springer Theses, Recognizing Outstanding Ph.D. Research, , 2190-Collana 5053 Disciplina 620.5 Soggetti Nanotechnology Biotechnology Energy harvesting **Electronics** Microelectronics Nanotechnology and Microengineering Microengineering **Energy Harvesting** Electronics and Microelectronics, Instrumentation Lingua di pubblicazione Inglese **Formato** Materiale a stampa Monografia Livello bibliografico "Doctoral Thesis accepted by Peking University, Beijing, China." Note generali Includes bibliographical references at the end of each chapters. Nota di bibliografia Nota di contenuto Supervisor's Foreword; Abstract; Acknowledgments; Contents; Abbreviations: 1 Introduction: Abstract: 1.1 Micro-Nanohierarchical Structures in Nature: 1.2 Artificial Micro-Nanohierarchical Structures: 1.2.1 The Progress of Bottom-Up Method; 1.2.2 The Progress of Top-Down Method; 1.3 The Development Progress of Microenergy Field; 1.3.1 Microenergy Technology; 1.3.2 Nanogenerator; 1.3.3 Triboelectric Nanogenerator; 1.4 Research Purpose and Content; 1.4.1 Research Purpose: 1.4.2 Research Content: References: 2 Micro-Nanointegrated Fabrication Technique for Silicon; Abstract 2.1 Nanoforest Fabrication Based on an Improved DRIE Process2.1.1 Deep Reactive-Ion Etching (DRIE) Process; 2.1.2 Nanostructuring by an Improved DRIE Process; 2.1.3 Mechanism of Controllable Formation of

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## Sommario/riassunto

This book presents a universal mass-production micro/nano integrated fabrication technology, which can be used to realize micro/nano hierarchical structures on Si-based materials and flexible polymeric materials. This fabrication technology has been systematically investigated by using experimental measurements, mechanism analyses, theoretical simulations and so on. Three common materials (i. e., silicon, PDMS and Parylene-C) with micro/nano hierarchical structures have been successfully fabricated, which also show several attractive properties. Furthermore, this book introduces this fabrication technology into microenergy field, and proposes several high-performance nanogenerators, of which practical applications have also been studied in commercial electronic device and biomedical microsystem.

5.1.1 Structural Design and Fabrication